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| FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) Date Submitted: August 31, 2004 | | | | ATTY DOCKET NO. 03500.017974 | | APPLICATION NO. 10/807,304 | |
| | | | | APPLICANT Toshimitsu KARIYA | | | |
| | | | | FILING DATE March 24, 2004 | | GROUP 1753 | |
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| EXAMINER /Jeffrey Barton/ | | | | DATE CONSIDERED 12/21/2007 | | | |

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



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| EXAMINER /Jeffrey Barton/ | | | DATE CONSIDERED 12/21/2007 | | |

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| FORM PTO 1449 (modified) <div style="text-align: center;"> SEP 22 2004 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) </div> Date submitted to PTO: September 22, 2004 | | ATTY DOCKET NO. 03500.017974 | | APPLICATION NO. 10/807,304 | |
| APPLICANT <div style="text-align: center;">Toshimitsu KARIYA</div> | | FILING DATE March 24, 2004 | | GROUP 1753 | |

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| [Table crossed out with a large X] | | | | | | | |

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